

H₂S Sensing Properties and Mechanism of Macroporous Semiconductor Sensors

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Macroporous (mp-) In₂O₃-based films with and without 1 wt% CuO loading were fabricated by a modified sol-gel technique employing polymethylmethacrylate microspheres as a template and their sensor responses to H₂S and the reaction behavior of H₂S over the sensor materials were investigated. Introduction of macropores into an In₂O₃ film and simultaneous loading of CuO on the In₂O₃ surface were enormously effective in improving the H₂S response. The large surface area of mp-In₂O₃ loaded with CuO, which increased the reactivity of CuO with H₂S, is probably the most important factor to enhance the H₂S response.

Introduction

Structural control of macropores as well as mesopores in gas-sensing materials is very essential for improving gas sensitivity and selectivity, because it provides suitable gas reactivity and diffusivity to semiconductor gas sensors. Therefore, we have so far developed mesoporous SnO₂ (> 300 m² g⁻¹ even after calcination at 600°C) (1) and its related materials (2-4) with high thermal stability and high specific surface area, and then demonstrated their potentials as gas sensor materials. In addition, we have recently fabricated various types of macroporous (mp-) oxide films, which have three-dimensionally (3D) ordered arrays of submicron-sized spherical pores, as promising gas-sensing materials by a modified sol-gel method (5-12) or some kinds of physical vapor deposition techniques (13, 14) employing polymethylmethacrylate (PMMA) microsphere templates. In these studies, it was confirmed that introduction of well-developed macropores into host sensor materials was also greatly effective in improving their gas sensing performances. The present study has been focused on the evaluation of H₂S sensing properties of mp-oxide sensors and discussion of their sensing mechanism.

Experimental

An aqueous suspension containing non-cross-linked PMMA microspheres (Soken Chem. & Eng., Co. Ltd., 400 or 800 nm in diameter (d)) was dip-coated on an alumina substrate, on which interdigitated Pt electrodes had been printed, and then it was dried at room temperature to obtain a 3D self-assembly of PMMA microspheres. Then, a 0.5 mol dm⁻³ In(NO₃)₃ precursor solution was impregnated into the openings of the 3D self-assembly. In some cases, an appropriate amount of CuCl₂ was added to the precursor solution to fabricate the oxide film mixed with 1 mol% CuO. The PMMA-precursor composite films were heated at 600°C for 2 h to form macroporous structure reflecting the 3D self-assembly of PMMA microspheres. These macroporous film sensors obtained were denoted as mp(d)-In₂O₃ or mp(d)-CuO/In₂O₃. Typical thick film sensors without macropores (R-In₂O₃ or R-CuO/In₂O₃) were also fabricated for reference. These oxide

powders were prepared by hydrolysis of the above-mentioned precursor solutions, followed by firing at 600°C for 2 h. Then, the powder was mixed with an appropriate amount of organic lacquer, and the mixture was screen-printed on the above-mentioned substrate. These sensors were subjected to firing at 550°C for 5 h.

Sensing properties to 10 ppm H₂S of these sensors were measured in air in a temperature range of 200~500°C. The magnitude of H₂S response was defined as the ratio of sensor resistance in air (R_a) to that in 10 ppm H₂S balanced with air (R_g).

Catalytic combustion behaviour of 500 ppm H₂S over mp(d)-CuO/In₂O₃ and R-CuO/In₂O₃ were investigated to clarify the H₂S-sensing mechanism. However, the catalytic properties of macroporous films themselves were hard to be measured due to their small volume. Therefore, a macroporous disc (ca. 1 mm thick and 10 mm in diameter) was prepared, as described below. At first, a disc of PMMA microspheres was prepared by uniaxial pressing (ca. 1 kgf cm⁻²). A small amount of the precursor solution stated above was permeated into the 3-D array of the PMMA disc in vacuo. They were calcined at 600°C for 2 h. On the other hand, powder of R-CuO/In₂O₃ was pressed into discs. The granules of about 0.5 g, which were prepared by pulverizing the discs obtained, were fixed in a glass reactor. Then, catalytic combustion behaviour of 390 ppm H₂S balanced with air over their granules was measured in a temperature range of 50~500°C at a flow rate of 50 cm³ min⁻¹ by using a gas chromatography-mass spectrometer (GC-MS, Shimadzu, QP-5050A). Temperature programmed desorption (TPD) spectra of SO₂ from mp(d)-CuO/In₂O₃ and R-CuO/In₂O₃ pretreated with 390 ppm H₂S balanced with air at 200°C for 3 h was carried out at a heating rate of 5°C under a He stream at a flow rate of 50 cm³ min⁻¹ by employing the same experimental setup as described above.

Specific surface area and pore size distribution of the granules of mp(d)-CuO/In₂O₃ and R-CuO/In₂O₃ were measured by a BET method using a N₂ sorption isotherm (Micromeritics, TriStar 3000). Morphology of macroporous films was observed by a scanning electron microscope (SEM, Hitachi, S-2250N) and a transmission electron microscope (TEM, JEOL, JEM2010-HT). Chemical binding states of constituent elements of R-CuO/In₂O₃, which was pretreated with and without 390 ppm H₂S balanced with air at 200°C for 0.5 and 10 h as well as treated under the same conditions as those for the TPD measurement, were characterized by X-ray photoelectron spectroscopy using MgK_α radiation (XPS, Shimadzu, ESCA-850), in which the binding energy was calibrated using the C1s level from usual contamination (284.5 eV).

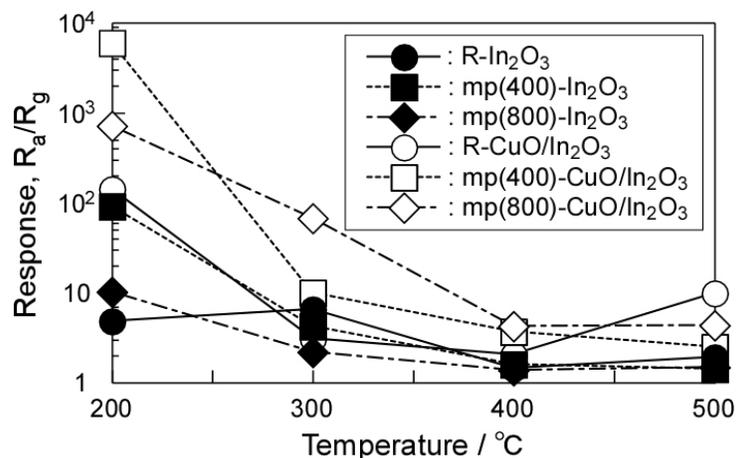


Figure 1. Temperature dependence of responses to 10 ppm H₂S of several sensors.

Results and Discussions

Temperature dependence of H₂S responses of the representative sensors fabricated is shown in Fig. 1. Addition of CuO to In₂O₃ improved the H₂S response of all sensors, as reported by Tamaki et al. (15, 16). Besides, introduction of macropores was largely effective in enhancing the response, especially for mp(d)-CuO/In₂O₃ sensors at temperatures of 300°C or less.

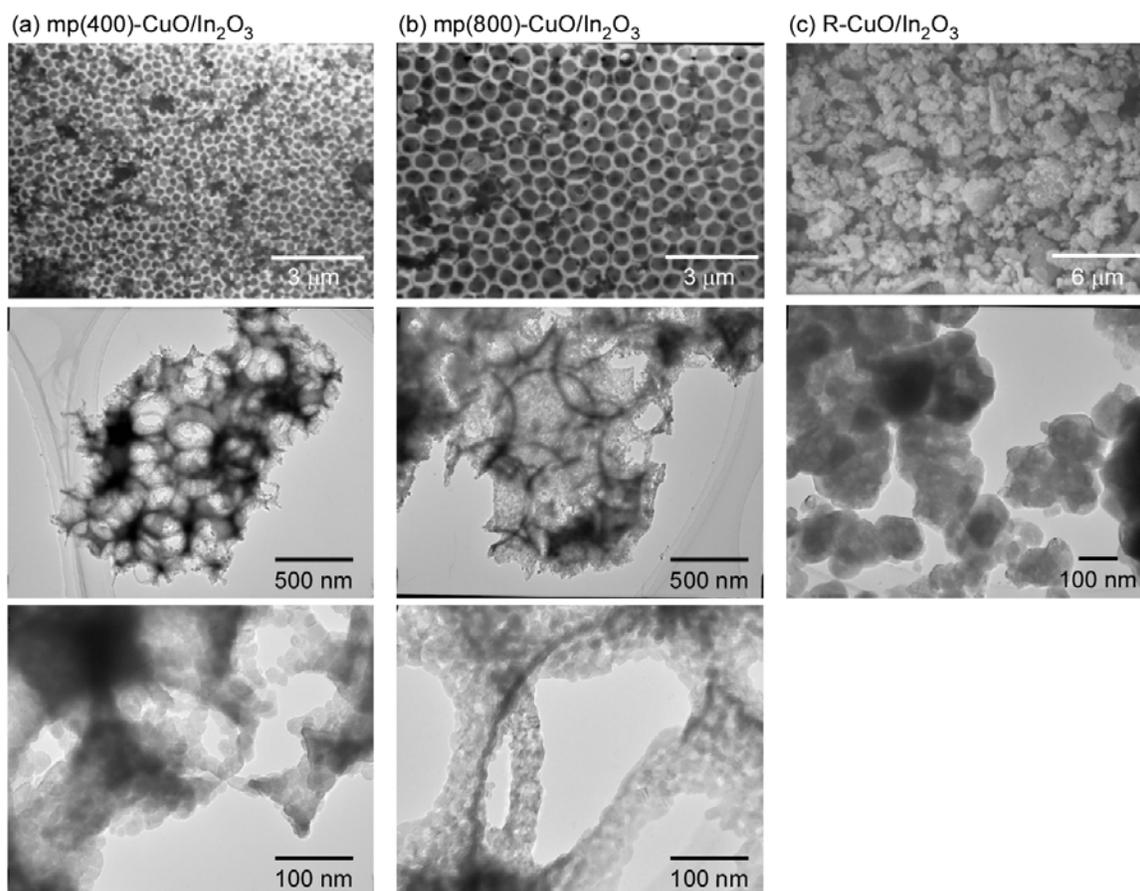


Figure 2. SEM and TEM photographs of mp(d)-CuO/In₂O₃ (d = 400 and 800 nm) and R-CuO/In₂O₃.

SEM and TEM photographs of CuO/In₂O₃ films with and without macropores are shown in Fig. 2. Well-developed and spherical macropores were observed on the surfaces of mp(400)-CuO/In₂O₃ and mp(800)-CuO/In₂O₃, and the spherical macropores reflecting the shape of the PMMA microspheres used were interconnected each other with small pores. The inner diameter of spherical macropores was ca. 300 and 600 nm with some exceptions for mp(400)-CuO/In₂O₃ and mp(800)-CuO/In₂O₃, respectively, and the size of both macropores reduced to ca. 80% of the size of each PMMA microsphere template. TEM photographs showed that the bulk of these macroporous films was also constituted with typically spherical macropores and the oxide walls around the macropores were constructed with nanoparticles of 17~20 and 12~15 nm in diameter for mp(400)-CuO/In₂O₃ and mp(800)-CuO/In₂O₃, respectively. In addition, the formation of well-developed mesopores was confirmed among these nanoparticles of both macroporous films. On the other hand, the surface of R-CuO/In₂O₃, which was

constituted with micron-size agglomerates, was enormously rough, and the TEM photograph showed that the particles were much larger than those of the macroporous films.

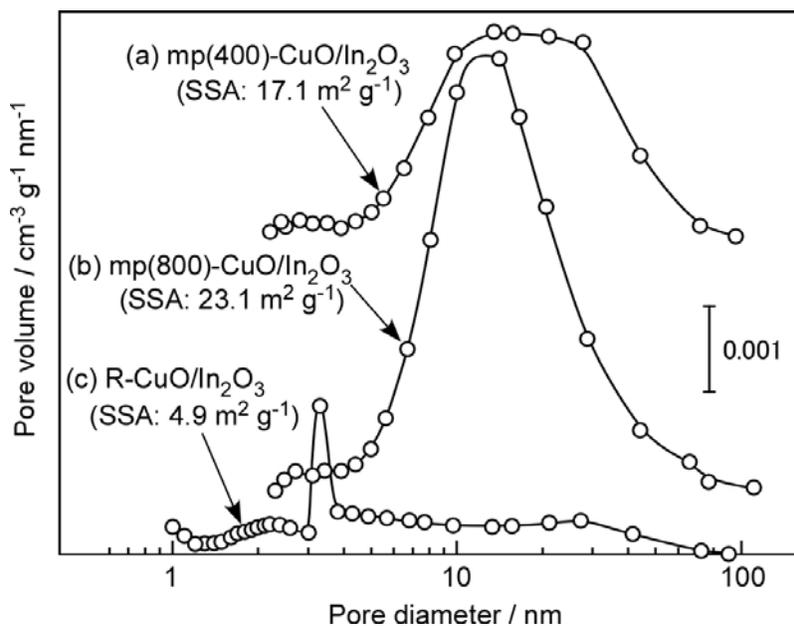


Figure 3. Pore size distributions of mp(d)-CuO/In₂O₃ (d = 400 and 800 nm) and R-CuO/In₂O₃.

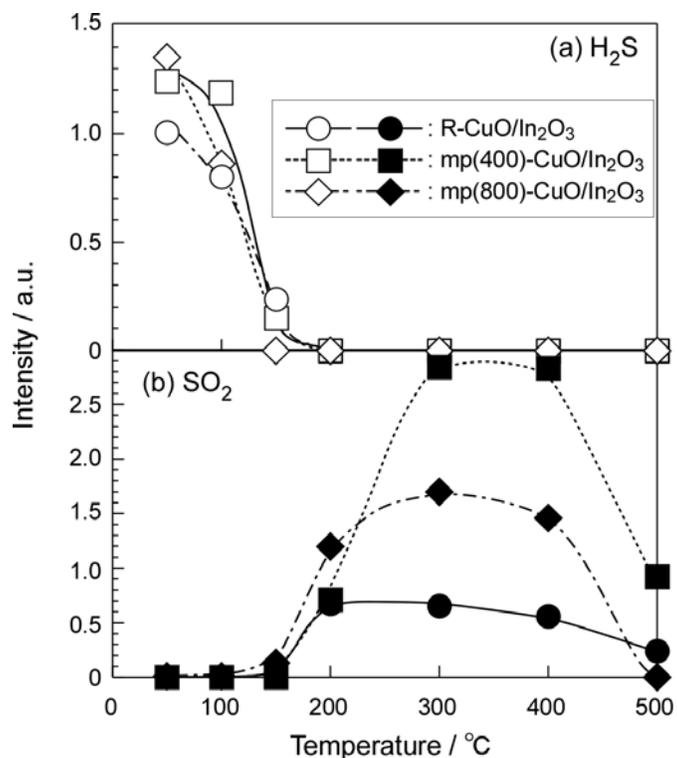


Figure 4. Catalytic combustion behavior of 390 ppm H₂S in air over mp(d)-CuO/In₂O₃ (d = 400 and 800 nm) and R-CuO/In₂O₃.

Figure 3 shows pore size distribution obtained from N₂ desorption behavior and specific surface area (SSA) of the three kinds of CuO/In₂O₃. mp(800)-CuO/In₂O₃ has a larger pore volume with a narrower pore size distribution centered at a pore diameter of ca. 12 nm and a larger surface area (23.1 m² g⁻¹) than those of mp(400)-CuO/In₂O₃ with broadly-distributed pores around 10~30 nm and a surface area of 17.1 m² g⁻¹. On the other hand, R-CuO/In₂O₃ had only a little and narrow peak at a diameter of ca. 3~4 nm, which seemed to be derived from bottleneck-type mesopores, with a small surface area (4.9 m² g⁻¹). By referring to such meso- and macro-structural characteristics shown in Figs. 2 and 3, small particle size, well-developed porous structure and large specific surface area of mp(d)-CuO/In₂O₃ are considered to be very effective for the improvement of H₂S-sensing properties.

Catalytic combustion behavior of 390 ppm H₂S in air over mp(d)-CuO/In₂O₃ and R-CuO/In₂O₃ powders was measured to clarify the above sensor behavior (see Fig. 4). It was confirmed that H₂S was oxidized and then SO₂ was produced in the temperature range higher than ca. 200°C. Figure 5 shows TPD spectra of SO₂ from the mp(d)-CuO/In₂O₃ and R-CuO/In₂O₃ powders pretreated with 390 ppm H₂S balanced with air at 200°C for 3 h. Desorption of SO₂ was observed in the temperature range higher than ca. 300°C. Figure 6 shows XPS spectra of Cu2p_{3/2} and S2p of R-CuO/In₂O₃ as a representative sample before and after the H₂S treatment and after the TPD measurement. As for Cu2p_{3/2}, peak B at 933.8 eV which is originated from CuO (16) appeared before the H₂S treatment. The peak B decreased after the H₂S treatment for 0.5 h and more, and then peak A at 933.0 eV originated from CuS (16) became the main peak after the H₂S treatment for 10 h. As for S2p, peaks C and D assigned to S2p_{3/2} and S2p_{1/2} of CuS, respectively, were obvious after the H₂S treatment for both 0.5 and 10 h, with a small peak E originated from a sulfate or sulfite (S⁶⁺) component. The peaks C and D increased with increasing the H₂S treatment time. No peaks originated from SO₂ (S⁴⁺) species could be confirmed after the H₂S treatment. After the TPD measurement, on the other hand, the peak B became the main peak along with a decrease in peak A, the peaks C and D disappeared and the peak E increased significantly.

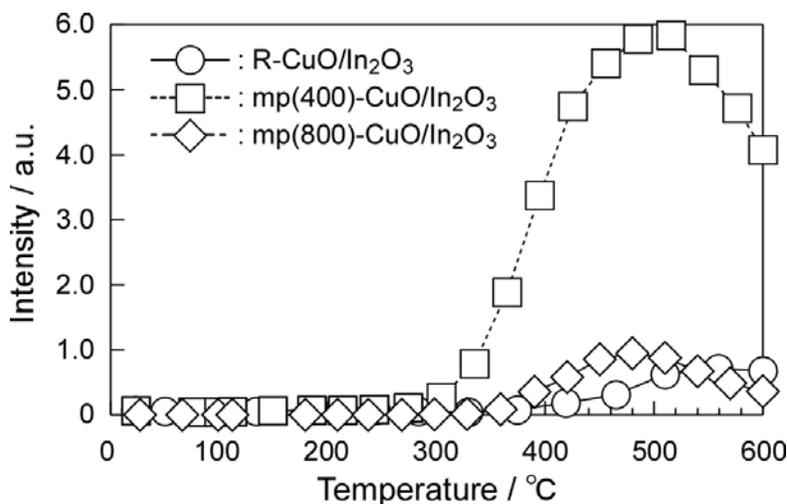


Figure 5. TPD spectra of SO₂ from mp(d)-CuO/In₂O₃ (d = 400 and 800 nm) and R-CuO/In₂O₃ pretreated with 390 ppm H₂S at 200°C for 3 h.

These results mean that CuS was easily produced by the reaction of H₂S molecules with CuO in H₂S balanced with air at 200°C, as also reported by Katti et al. (17) and Niranjani et al. (18). Simultaneously, the H₂S molecules are oxidized to SO₂ at the same atmosphere, but such S⁴⁺-species are not adsorbed on the oxide surface (compare Fig. 4 with Fig. 6). On the other hand, the most part of SO₂ desorbed in the temperature range higher than ca. 300°C in TPD measurement (Fig. 5) is considered to be originated from those produced by the re-oxidation of CuS. Chemisorbed and/or lattice oxygen of In₂O₃ might react with CuS during the heating process. The large amount of SO₂ desorbed from mp(d)-CuO/In₂O₃ is ascribed reasonably to its relatively large surface area, in comparison with that of R-CuO/In₂O₃. The larger the surface area, the smaller the CuO particles dispersed on the surface of In₂O₃. This leads to an increase in effective volume of CuO to be reacted with H₂S and then larger H₂S response.

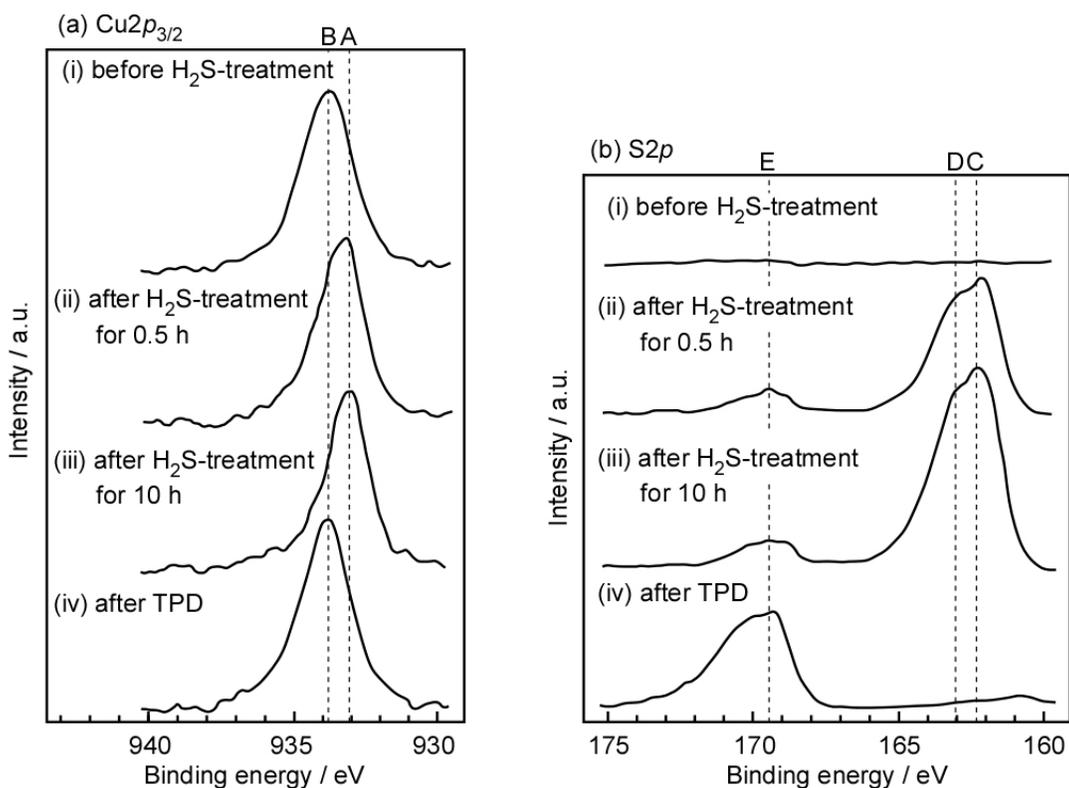


Figure 6. XPS spectra of (a) Cu_{2p_{3/2}} and (b) S_{2p} of R-CuO/In₂O₃ before and after H₂S treatment, along with that after TPD measurement.

Conclusions

Macroporous In₂O₃-based films could be fabricated by a modified sol-gel technique employing two kinds of PMMA microsphere templates (d: 400 or 800 nm). Their films were constructed with spherical macropores interconnected each other with small pores and the oxide frameworks containing nanoparticles and mesopores. In addition, they showed a large surface area with well-developed mesopores among nanoparticles in the oxide frameworks. CuO loaded on the surface of In₂O₃ was confirmed to be converted to CuS by the reaction with H₂S molecules, from the experimental results of catalytic combustion, TPD and XPS measurements. The large surface area of mp(d)-CuO/In₂O₃ promoted the reaction of CuO with H₂S and then improved the H₂S response.

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